



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/776,553  
Filing Date ..... February 10, 2004  
Inventor ..... Weimin Li et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1755  
Examiner ..... Carol M. Koslow  
Attorney's Docket No. .... MI22-2497  
Title: ..... Compositions of Matter and Barrier Layer Compositions

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References –See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether the listed references are prior art.

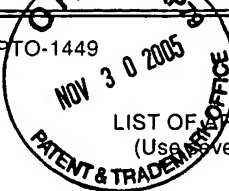
Respectfully submitted,

Dated:

November 30, 2005

By:

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711

		Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2497		SERIAL NO. 10/776,553	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Weimin Li et al.			
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U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Sub- class	Filing Date If Appropriate
	AA	5,840,610	11/1998	Gilmer et al.			
	AB	4,523,214	06/1985	Hirose et al.			
	AC	6,432,791 B1	08/2002	Hutter et al.			
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	AJ	2003/0207594	11/2003	Catabay et al.			
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub- class	Translation Yes No
	AN	JP8051058	02/1996	Japan			
	AO	JP63316476	12/1988	Japan			
	AP	TW 47112A	01/2002	Taiwan			
	AQ	JP8078322	03/1996	Japan			
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR	Stanley Wolf, SILICON PROCESSING FOR THE VLSI ERA, Vol. 3, Lattice Press 1995, page 635.					
	AS	Wolf et al., Silicon Processing for the VLSI Era, 1986, Lattice Press, Volume 1, Pages 1 and 2.					
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							